FIG.1

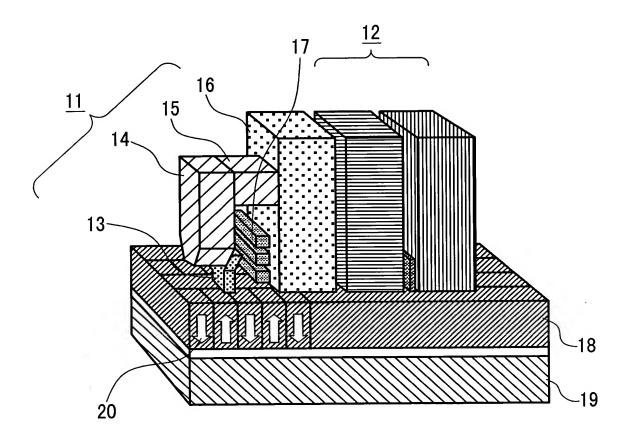
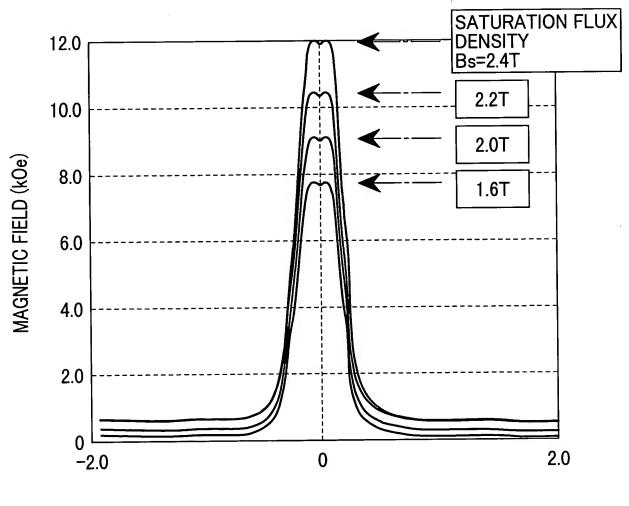
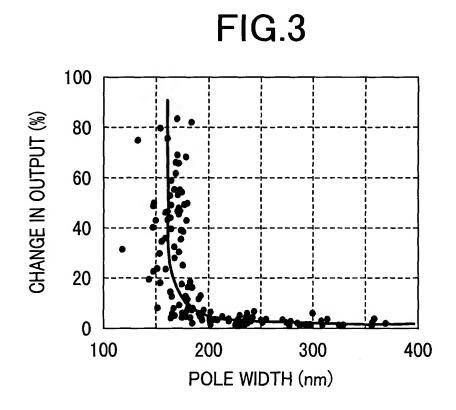


FIG.2



POSITION (μ m)



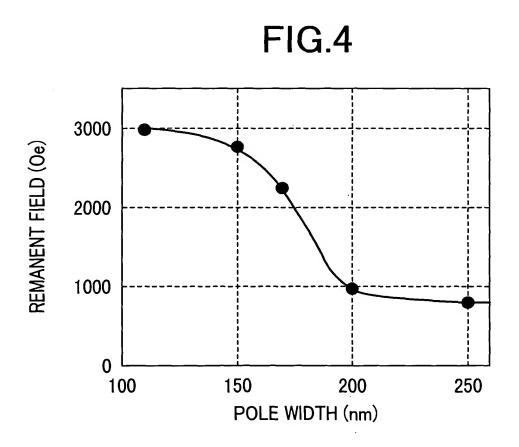


FIG.5A

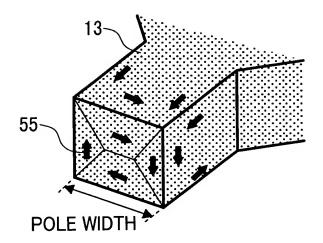


FIG.5B

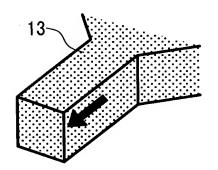


FIG.6

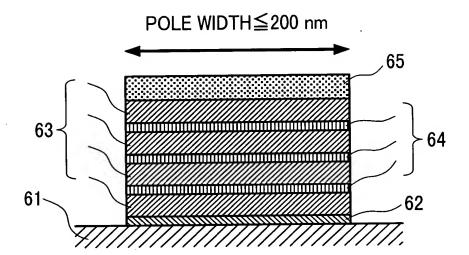


FIG.7

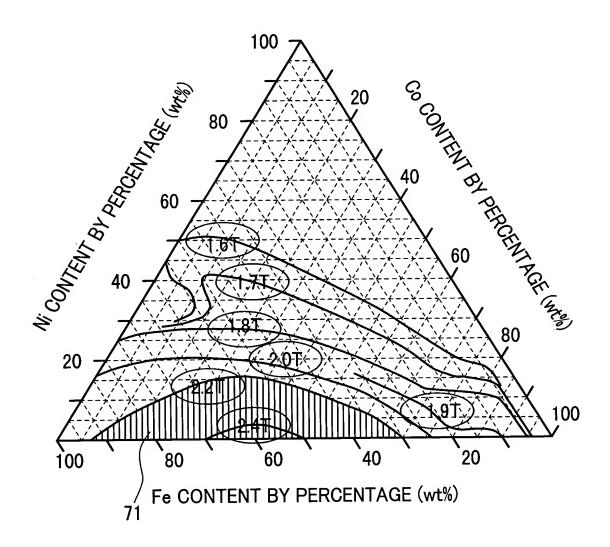


FIG.8

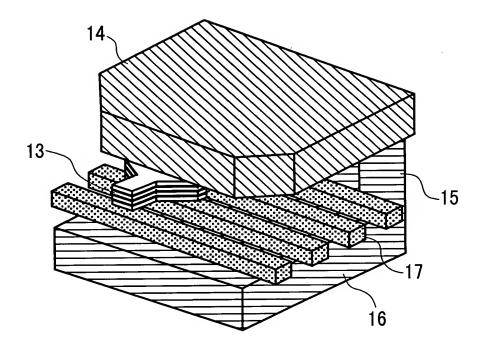


FIG.9A

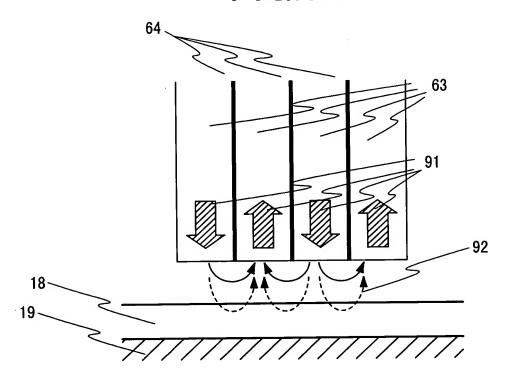


FIG.9B

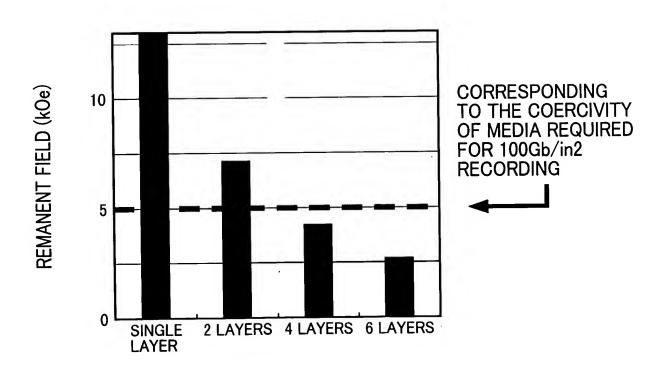
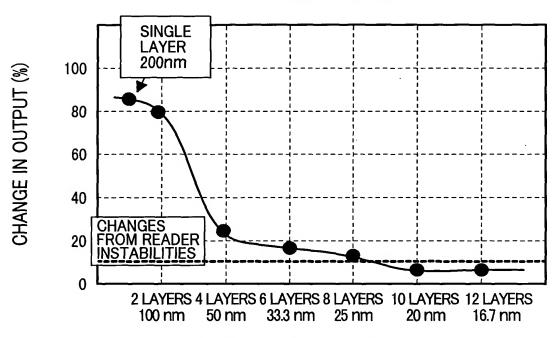
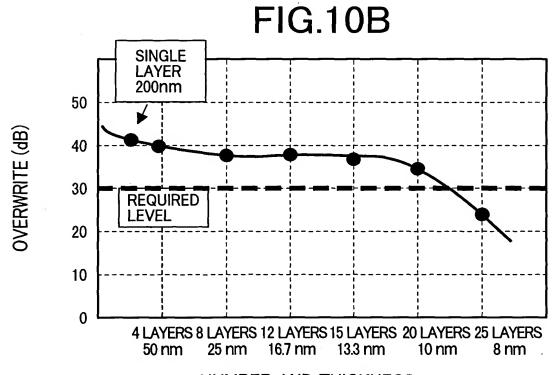


FIG.10A



NUMBER AND THICKNESS OF LAYER WITH HIGH Bs (nm)



NUMBER AND THICKNESS OF LAYER WITH HIGH Bs (nm)

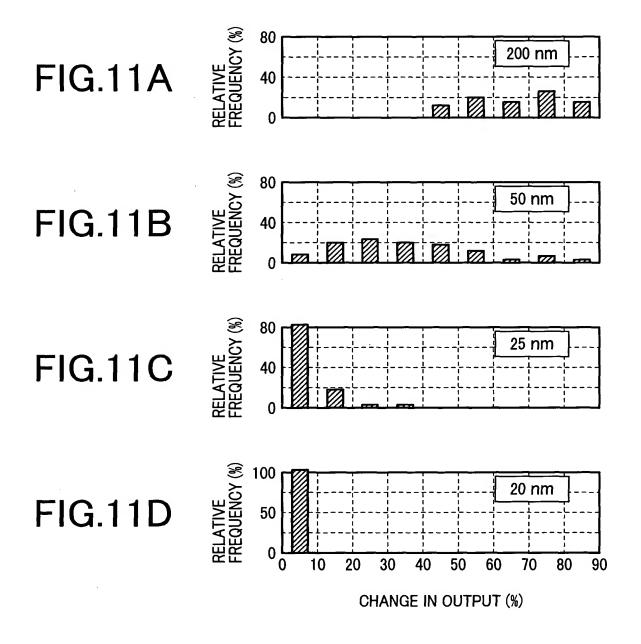
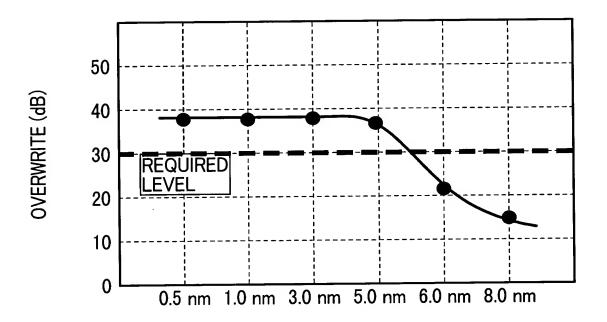


FIG.12



THICKNESS OF LAYER WITH LOW Bs (nm)

FIG.13

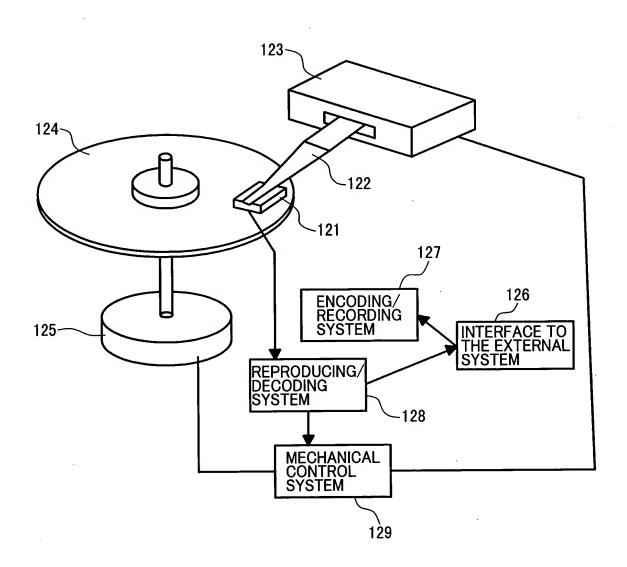


FIG.14A

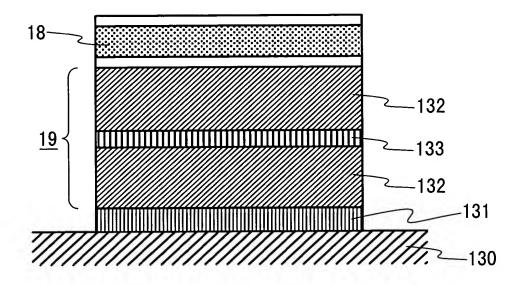


FIG.14B

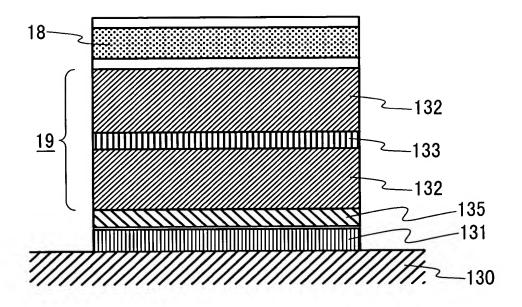


FIG.15

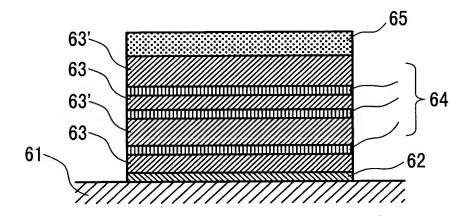


FIG.16

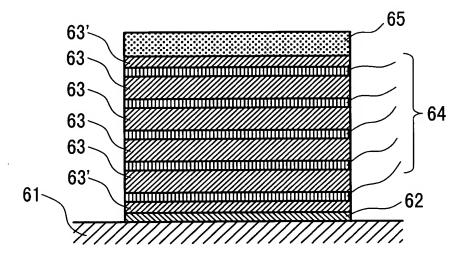


FIG.17

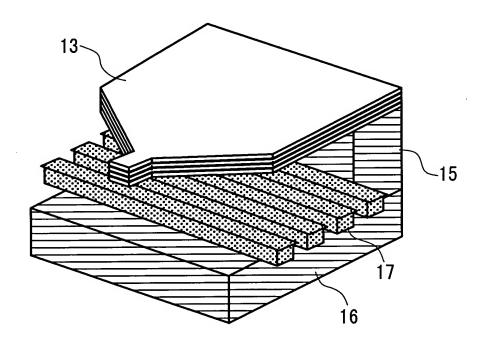


FIG.18

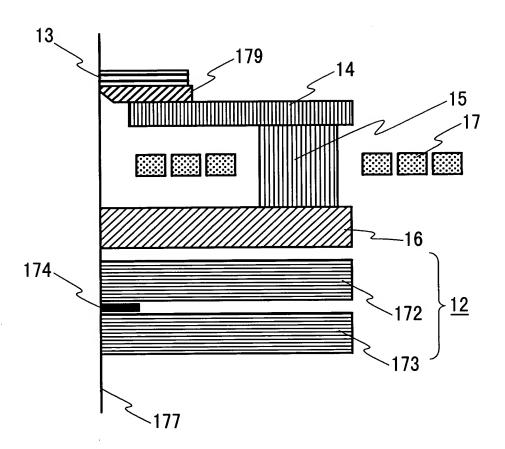


FIG.19

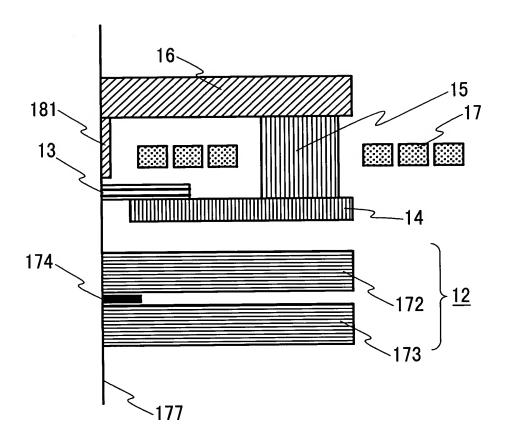


FIG.20A

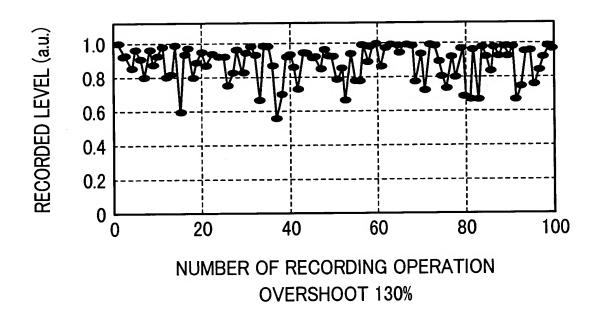


FIG.20B

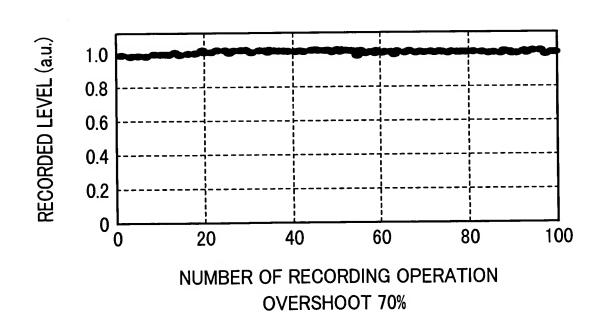


FIG.21

